



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of :
Tuqiang NI et al :
Serial No. 09/689,616 : Group Art Unit: 1763
Filed: October 13, 2000 : Examiner: L. Alejandro Mulero
For: VACUUM PLASMA PROCESSOR HAVING A CHAMBER WITH ELECTRODES
AND A COIL FOR PLASMA EXCITATION AND METHOD OF OPERATING
SAME

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RESPONSE TO RESTRICTION REQUIREMENT

Honorable Commissioner of
Patents and Trademarks
Washington, D. C. 20231

Sir:

Applicants respond to the December 7, 2001, Restriction Requirement by electing, without traverse, the apparatus claims 1-32. Applicants reserve the right to file a divisional application on the invention of method claims 33-39. An action on the merits of claims 1-32 is in order.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including

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extension of time fees, to Deposit Account 07-1337 and please credit any excess fees to such deposit account.

Respectfully submitted,

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Date: December 28, 2001